

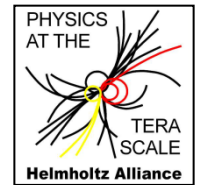
Impact of low-dose electron irradiation on the charge collection of n⁺p silicon strip sensors

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for the

CMS Tracker Collaboration

+Hamburg University



*This presentation was held by R. Klanner at the TIPP conference in Amsterdam on June 6th 2014

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Introduction

- **Silicon detectors:** The central detectors of most collider experiments
- **Silicon detectors** have shown extraordinary performance
! no Si = no Higgs, no precision top-, b-physics, and more !
- The **HL-LHC** (High-Luminosity LHC) upgrade poses extraordinary challenges
 - **Track densities**
 - **Hadron fluences** ($10^{16} n_{eq}/cm^2$)
 - **Surface damage** (MGy's in SiO_2)
- **ATLAS** and **CMS** have decided on n^+ p sensors and binary readout for **tracker**
- Decision for **pixels** progressing



This work: Study effects of low-dose irradiations by a β -source on the charge collection properties of non-irradiated and irradiated n^+ p sensors + discuss relevance for HL-LHC upgrade

Sensors investigated

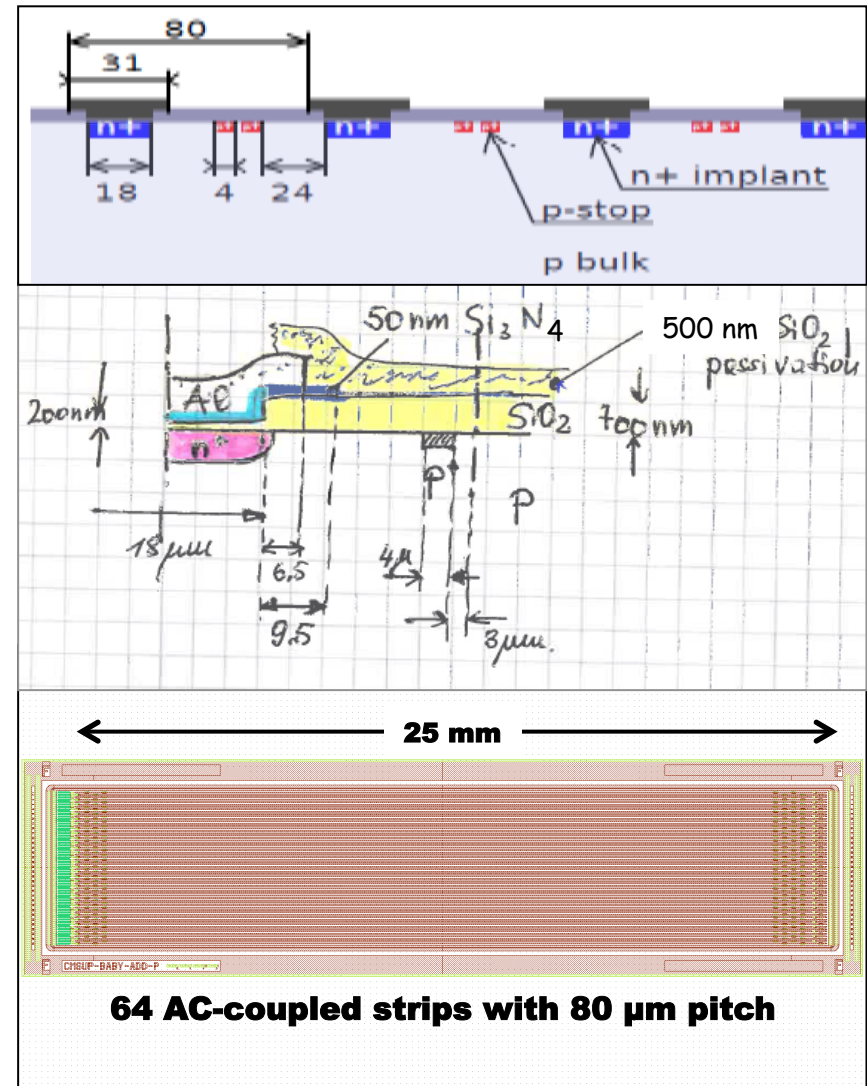
"Baby add. from HPK Campaign"

- FZ p-doping: $3.7 \cdot 10^{12} \text{ cm}^{-3}$
- [O]: $\sim 5 \cdot 10^{16} \text{ cm}^{-3}$
- p-spray: $\sim 5 \cdot 10^{10} \text{ cm}^{-2}$
- p-stop: $\sim 2 \cdot 10^{11} \text{ cm}^{-2}$
- 64 AC-coupled strips
- Strip length: 25 mm
- Pitch: $80 \mu\text{m}$
- Implant width: $19 \mu\text{m}$
- Al overhang: $5 \mu\text{m}$
- d_{Si} : $200 \mu\text{m}$
- d_{SiO_2} : $650 \text{ nm} + 130 \text{ nm}$
- $d_{\text{Si}_3\text{N}_4}$: 50 nm

Irradiations:

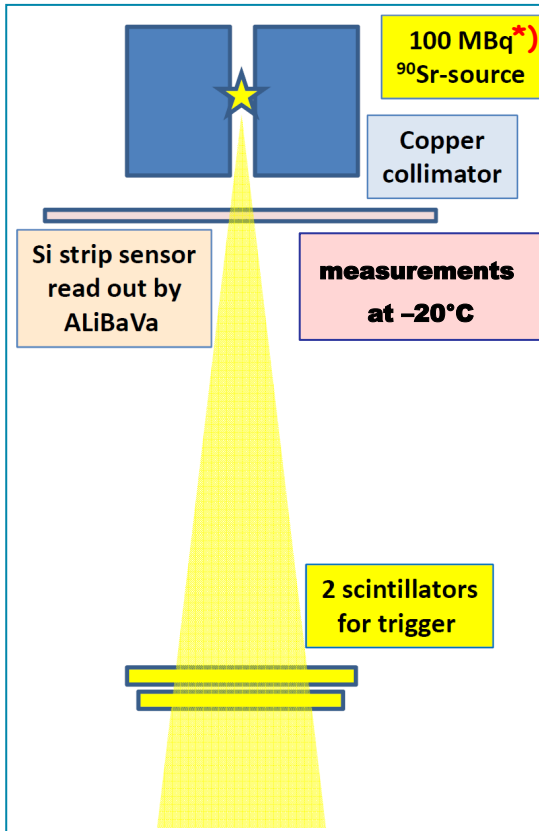
- No irradiation
- Irradiation [cm^{-2}]: **23**
GeV protons $15 \cdot 10^{14}$ 1MeV neq +
reactor neutrons $6 \cdot 10^{14}$ 1MeV neq
 → $r \sim 15 \text{ cm}$ for 3000 fb^{-1} HL-LHC
 (→ $\sim 750 \text{ kGy}$ ionizing dose in SiO_2)

Details of sensor layout (p-stop):



Measurement setup + dose rates

Layout, readout + e-irradiation



Energy spectra for electrons and γ 's from ^{90}Sr in SiO_2

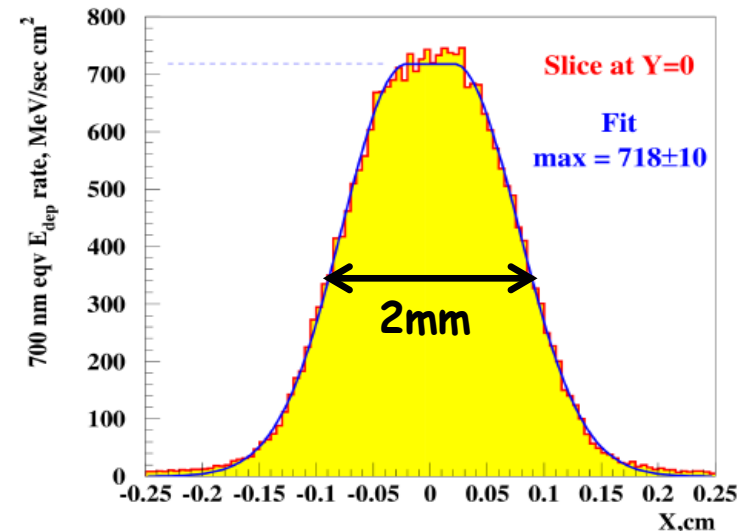
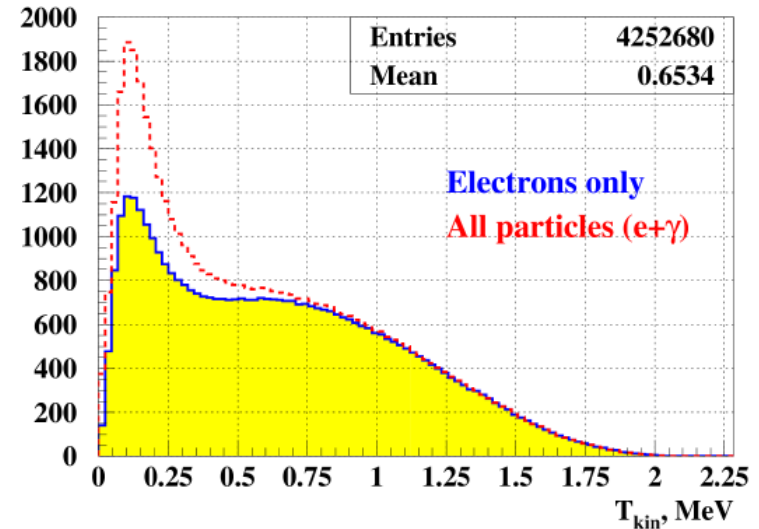
Rate:

- SiO_2 : 50 Gy/day (0(2%) HL-LHC)
- Si-bulk: 10^8 neq/($\text{cm}^2 \cdot \text{day}$)

Width: ~2 mm

Proj. angular spread: ± 100 mrad ($\pm 20 \mu\text{m}$ for $200 \mu\text{m}$)

dE/dx for trigger e:
Landau mpv= 56keV (54keV for mip)



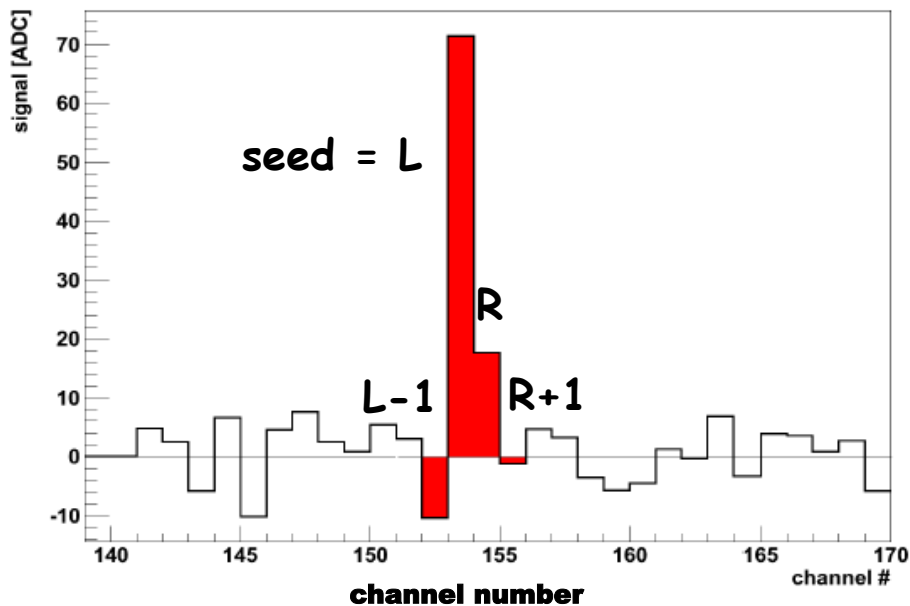
^{*)} Measurements also with 37 MBq ^{90}Sr source

Compared to HL-LHC (or XFEL) very low local doses and dose rates

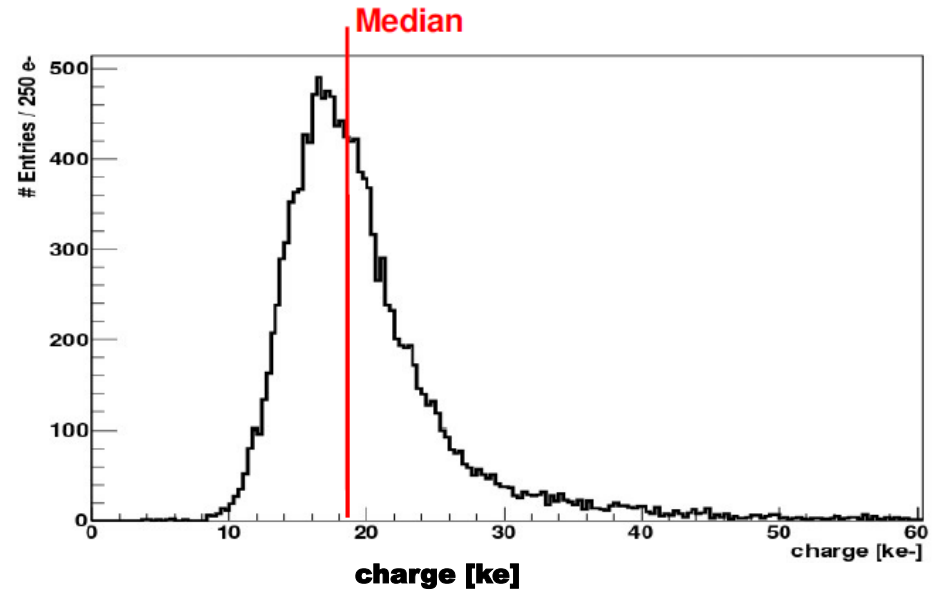
Analysis

- Select events ± 5 ns in phase with 40 MHz clock
- **Seed**: biggest signal in event
- **4 signal strips**: L-1, L, R, R+1
- **4-cluster PH**: Σ (4 signal strips)

Strip pulse heights for single event



4-cluster pulse height for 5000 events

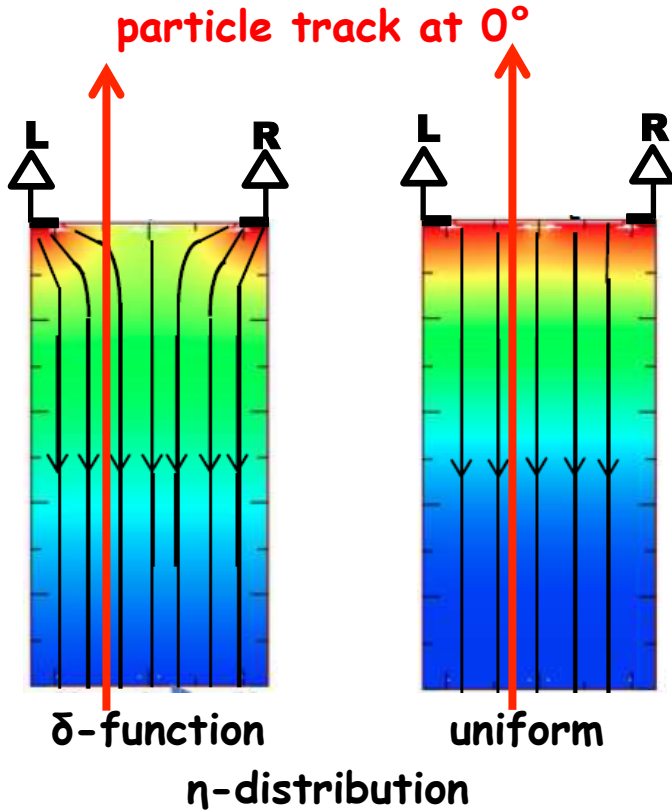


Comment: As individual pulse height distributions \neq Landau distributions, we prefer to use **median**; statistical uncertainty similar to **Gauss \times Landau fits**, however sensitive to noise pulses!

Analysis

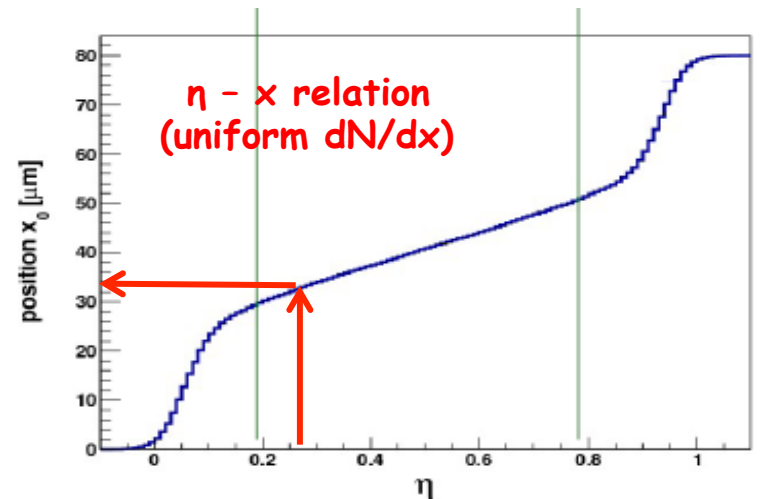
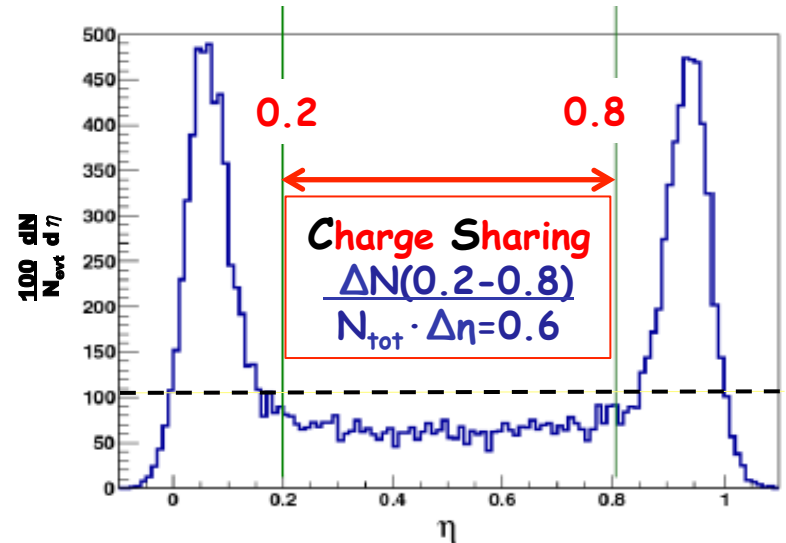
Charge sharing:

$$\eta = \frac{PH(R)}{PH(L) + PH(R)} \quad *)$$



CS \ll 1

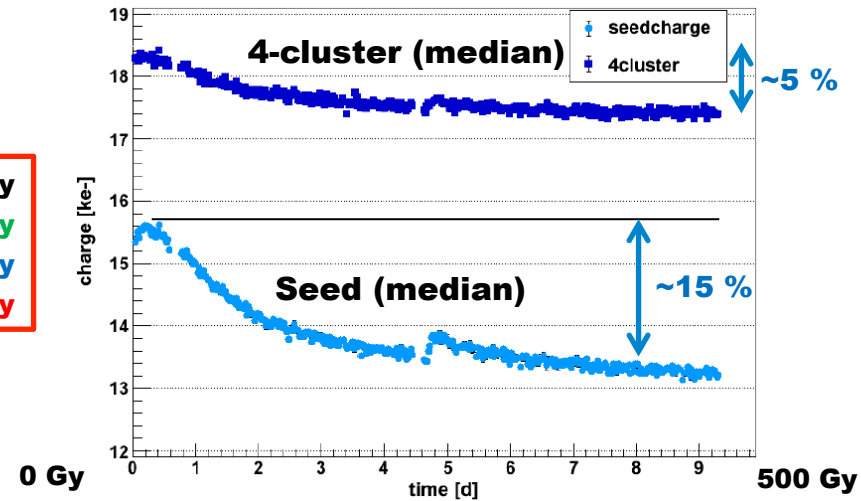
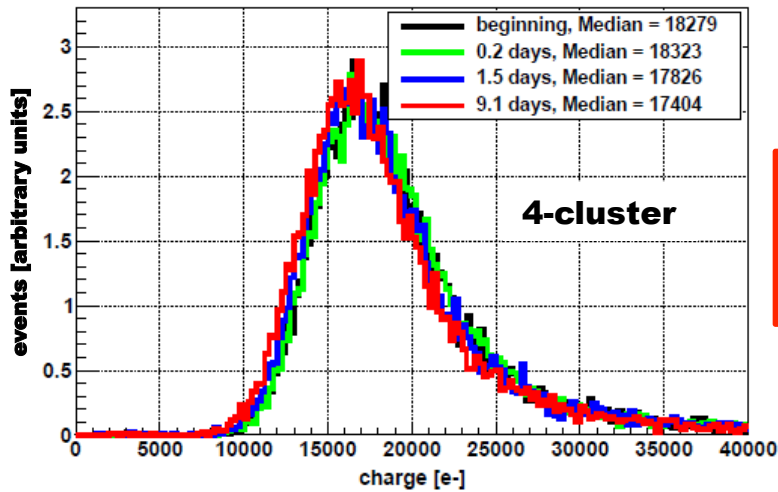
CS = 100%



*) E.Belau et al., NIM 214 (1983) 253

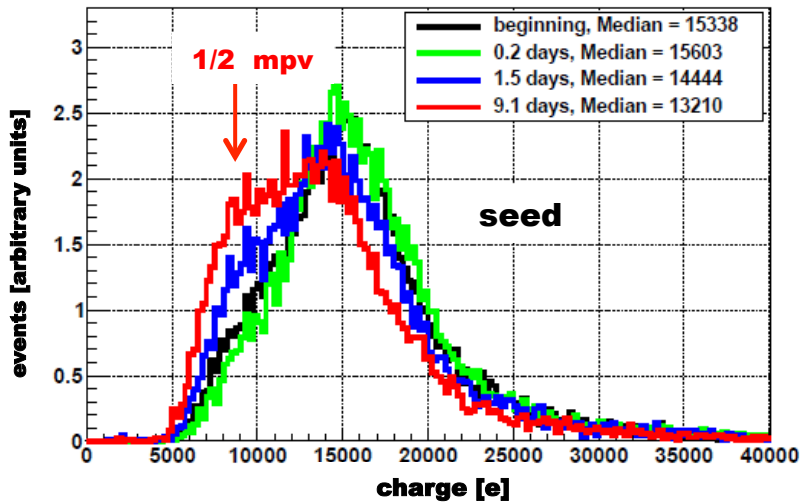
η -distribution -> Information on E-field + particle track position

Observations for $V_{bias} = 600\text{ V}$ (non irr. p-stop sensor)

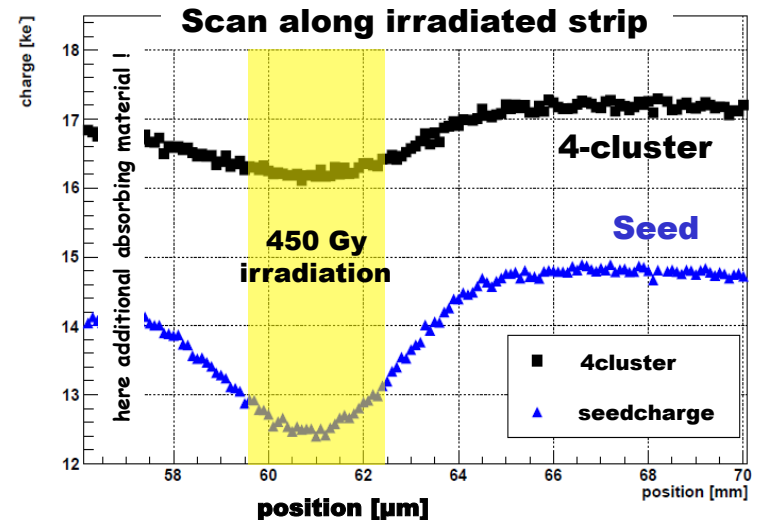


Little change in 4-cluster distribution

Decrease in PH(seed) and PH(4-cluster)

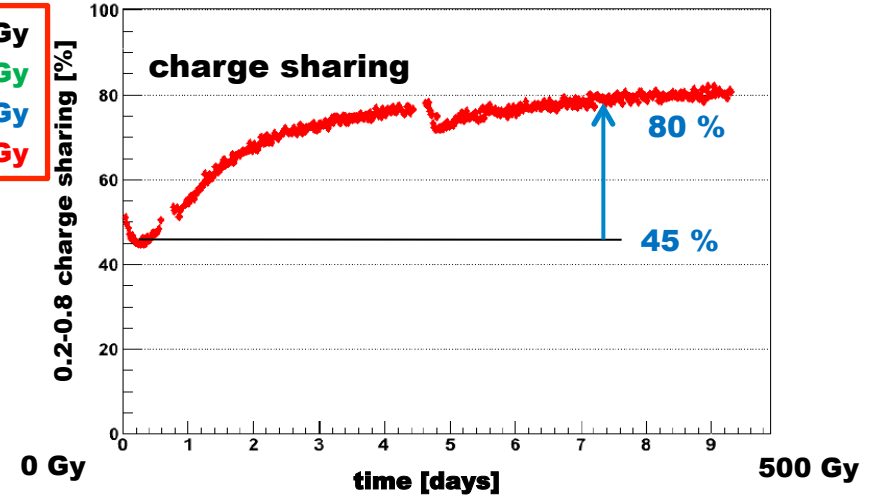
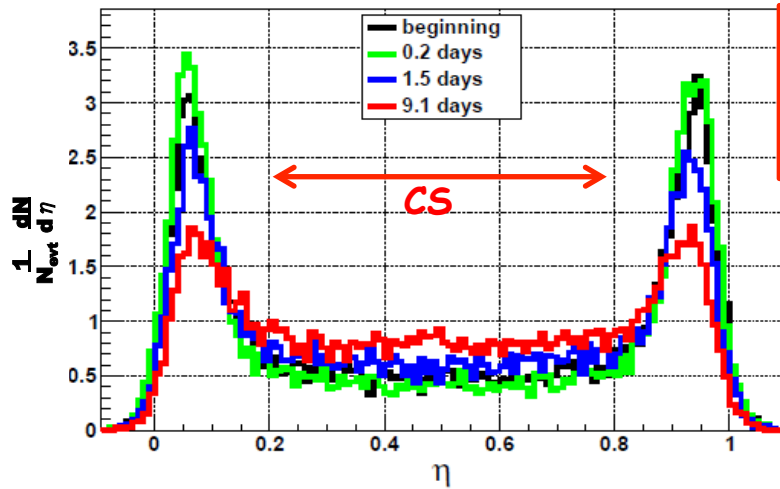


Change in seed distr. - events at $<0.5 \cdot mpv$!



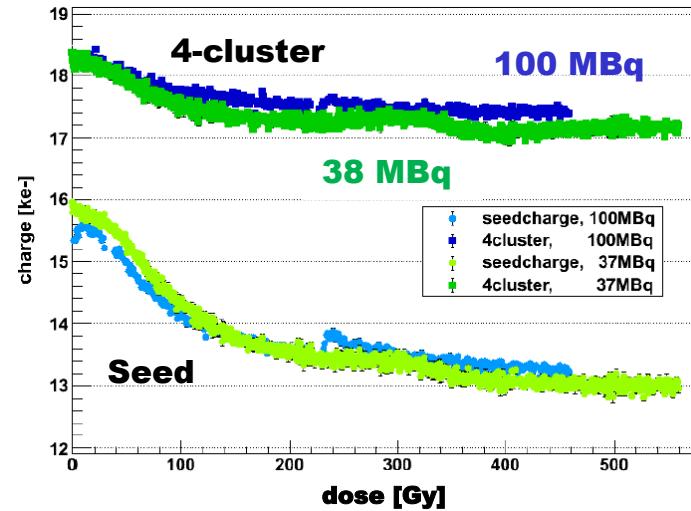
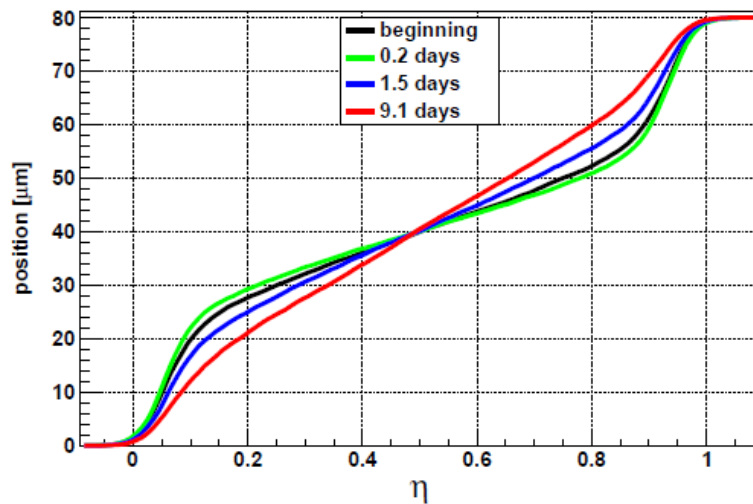
Effect only where sensor irradiated

Observations for $V_{bias} = 600$ V (non irr. p-stop sensor)



Significant increase in charge sharing

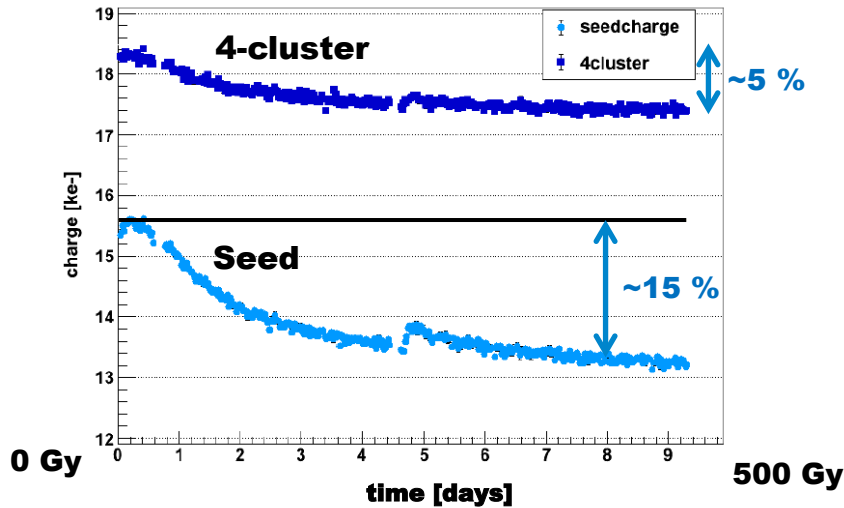
Increase in charge sharing



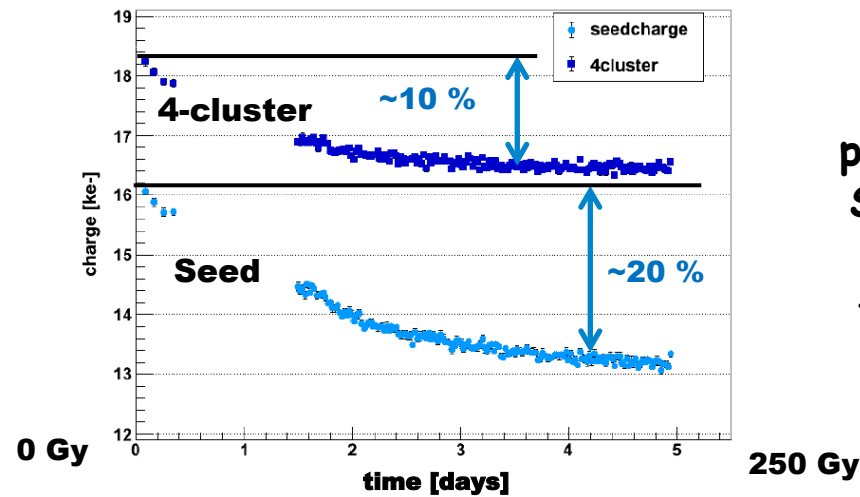
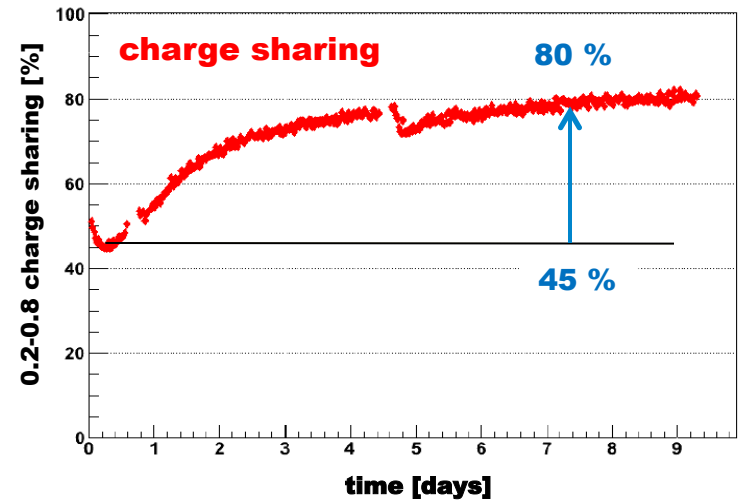
Change of η vs. position relation

Change depends on dose - not dose rate

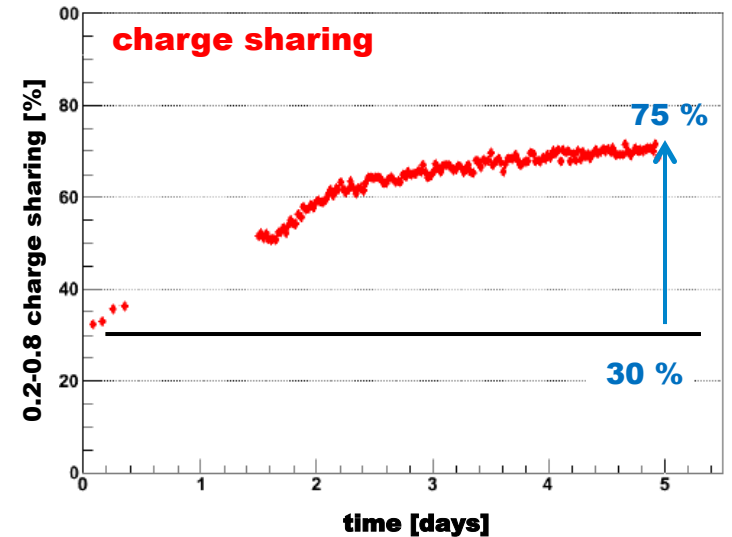
Comparison p-stop vs. p-spray (non-irradiated)



p-stop
Sensor
600 V
-20°C

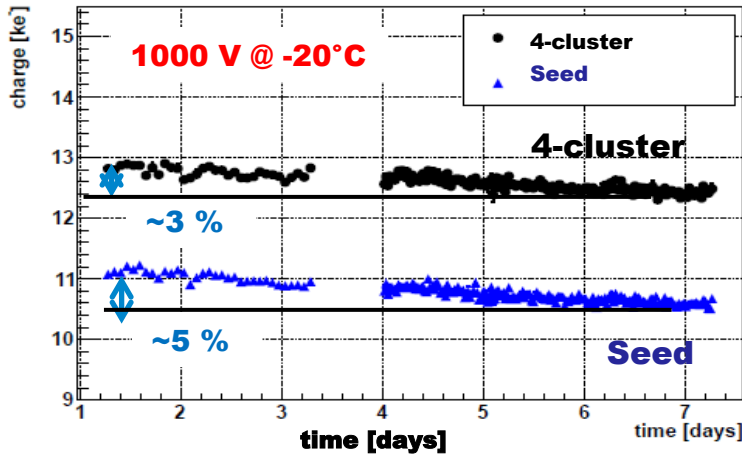


p-spray
Sensor
600 V
-20°C

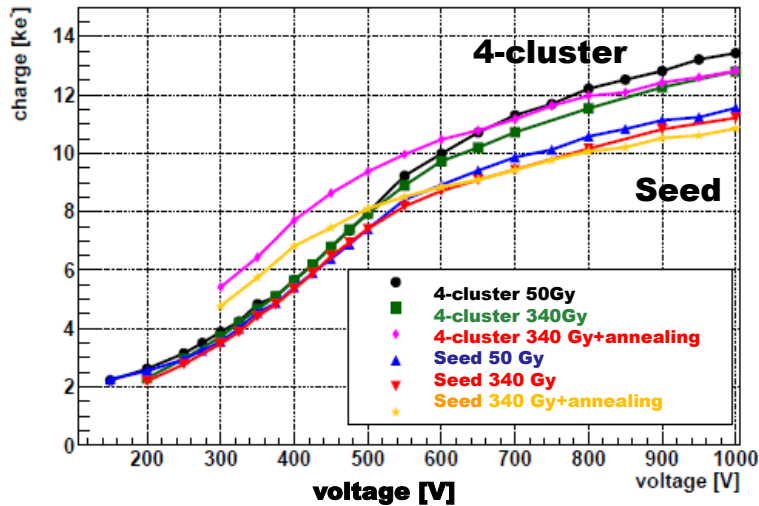
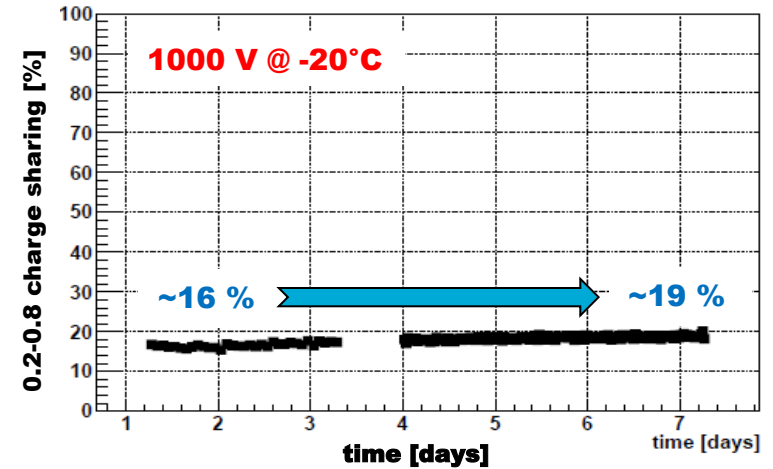


Effects **bigger** for p-spray than for p-stop sensor

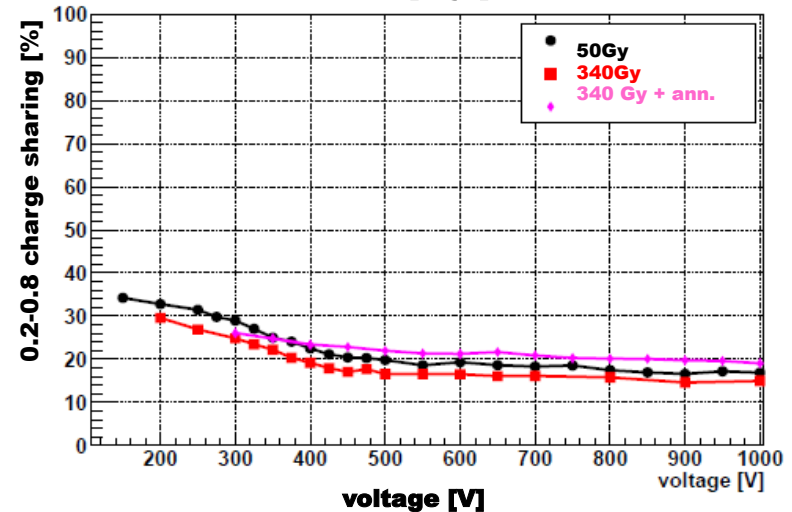
Irradiated (p-stop) sensor @ 1000 V



irradiated
 $15 \cdot 10^{14}$ GeV p
 $+6 \cdot 10^{14}$ n
 p-spray
 Sensor
 1000 V
 -20°C



annealing =
 12 h @ 80°C



**Small effect for irradiated sensor at 1000 V
 + annealing has only a small effect**

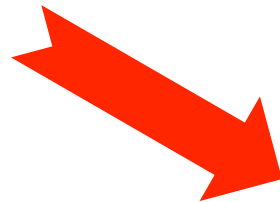
Summary of observations → surface damage

Low dose [O(kGy)] ionizing irradiation changes charge collection in n+p Si strip sensors: **Increase in charge sharing + increase in charge losses**

- Effect decreases with: p-spray → p-stop → hadron irradiated sensor

Suspected cause: **Surface damage + charge build-up in/on insulators**

Surface damage is complicated !!!



We will **only** consider build up of surface charges with density

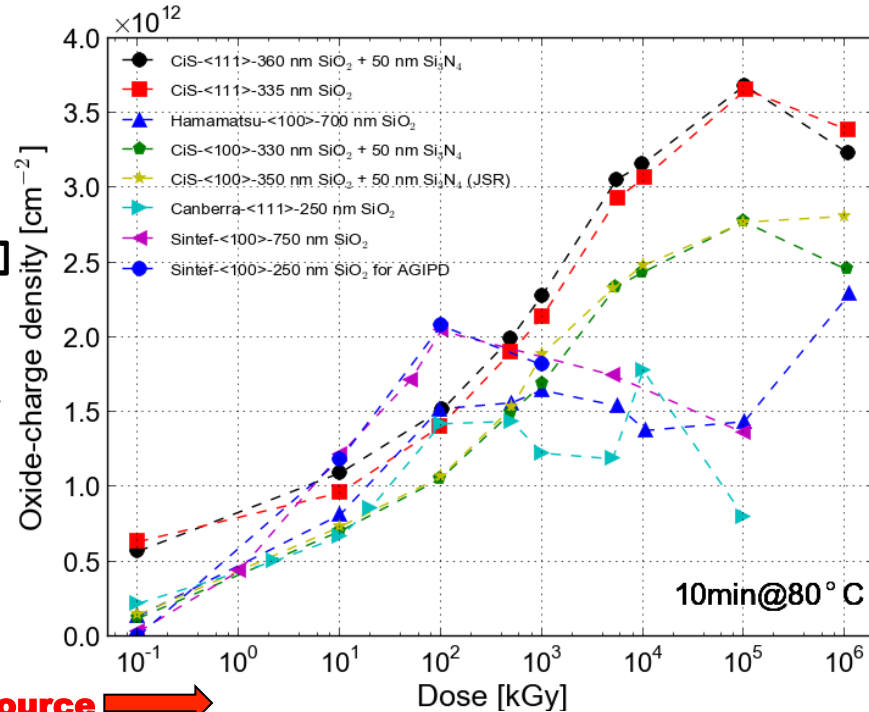
N_{ox} @doses <1 kGy*):
 few · 10¹⁰ cm⁻² <100>
 ~ 10¹¹ cm⁻² <111>
+4 · 10¹¹ cm⁻² · D[kGy]

and effects of surface boundary conditions

for more information see:

- * J.Zhang et al., JSR 19 (2012) 340;
- J. Schwandt et al., arXiv-140213;
- T.Poehlsen et al., NIM-A 721 (2013) 26.

N_{ox} [10¹²cm⁻²]
 for different producers,
 crystal orient.
 d_{ox} , etc.



β-source →

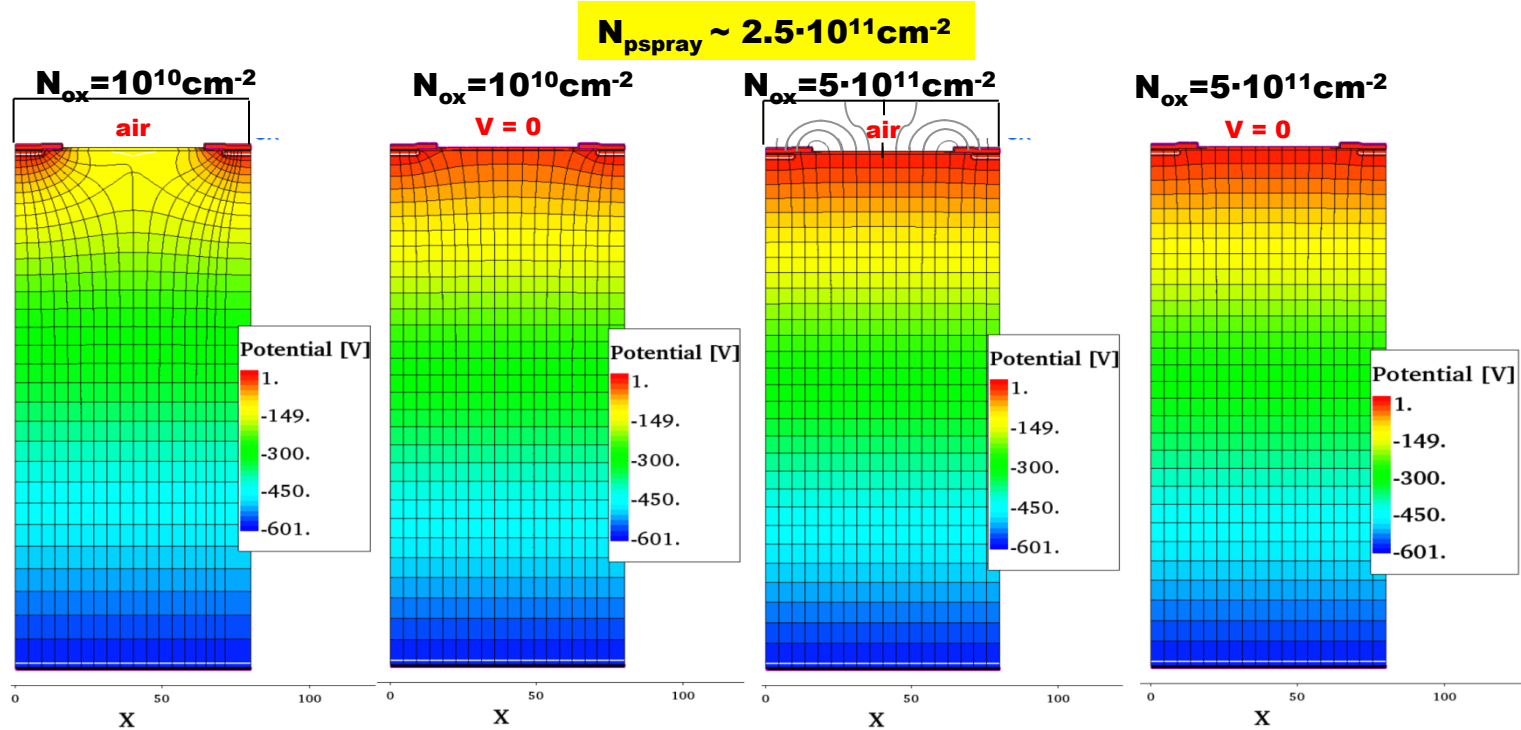
HL-LHC →

XFEL →

Synopsys TCAD simulation of p-spray sensor vs. N_{ox}

Results on simulations depend also on boundary conditions:

1. "Dirichlet": SiO_2 surface on potential of readout strips (0 V)
2. "Air": 500 μm above strips Dirichlet with potential of readout strips

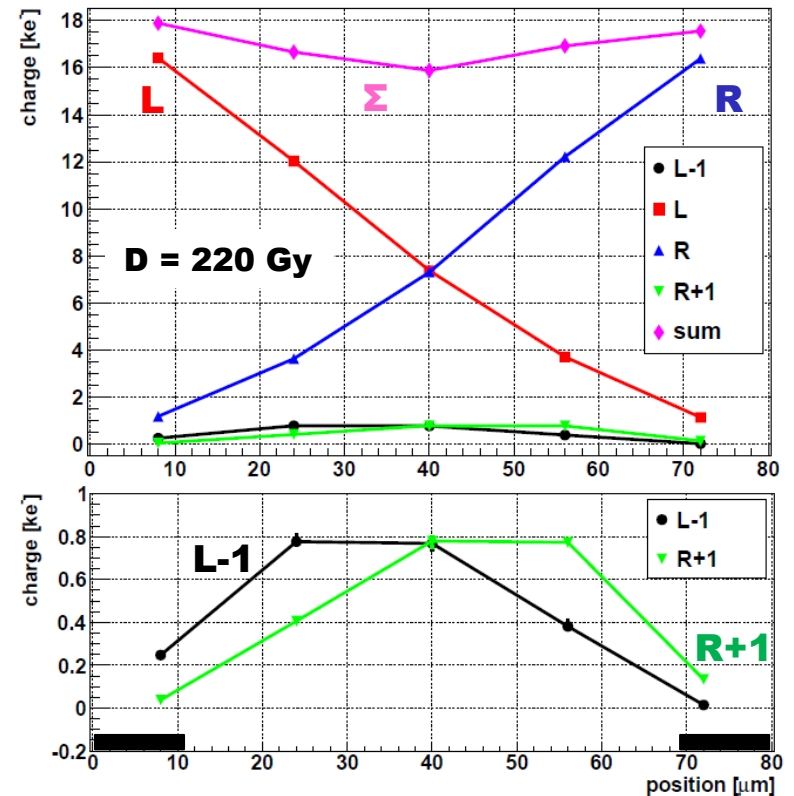
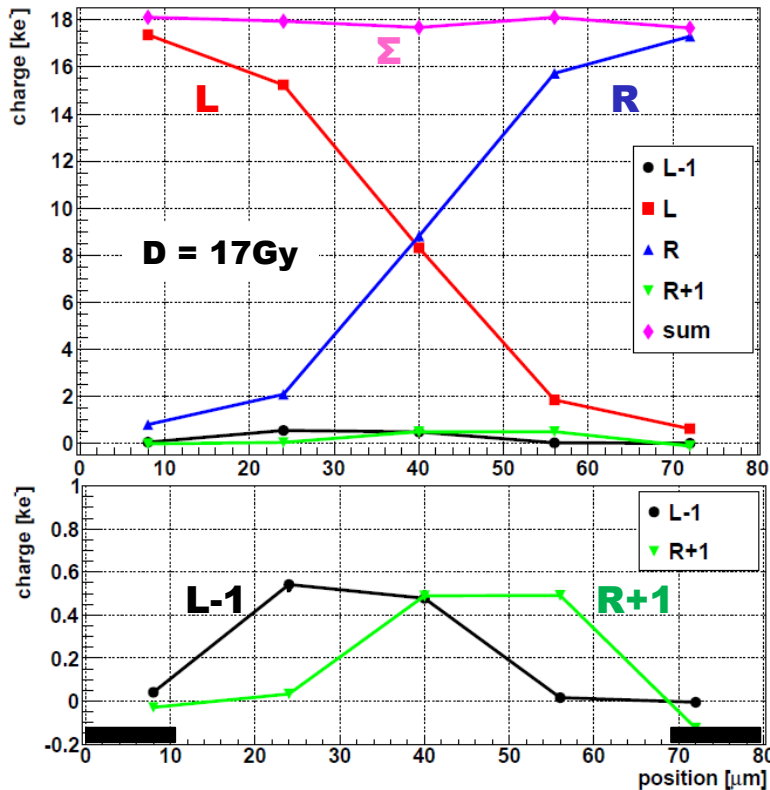


$N_{ox} < N_{p-spray}$: E-field lines end at readout strips \rightarrow no charge sharing
 $N_{ox} > N_{p-spray}$: E-field lines end at Si-SiO₂ interface \rightarrow charge sharing

Increase of oxide charge density $N_{ox} \rightarrow$ Change of charge sharing

Charge sharing and charge losses

Using the η - x transformation we can study pulse-heights vs. position



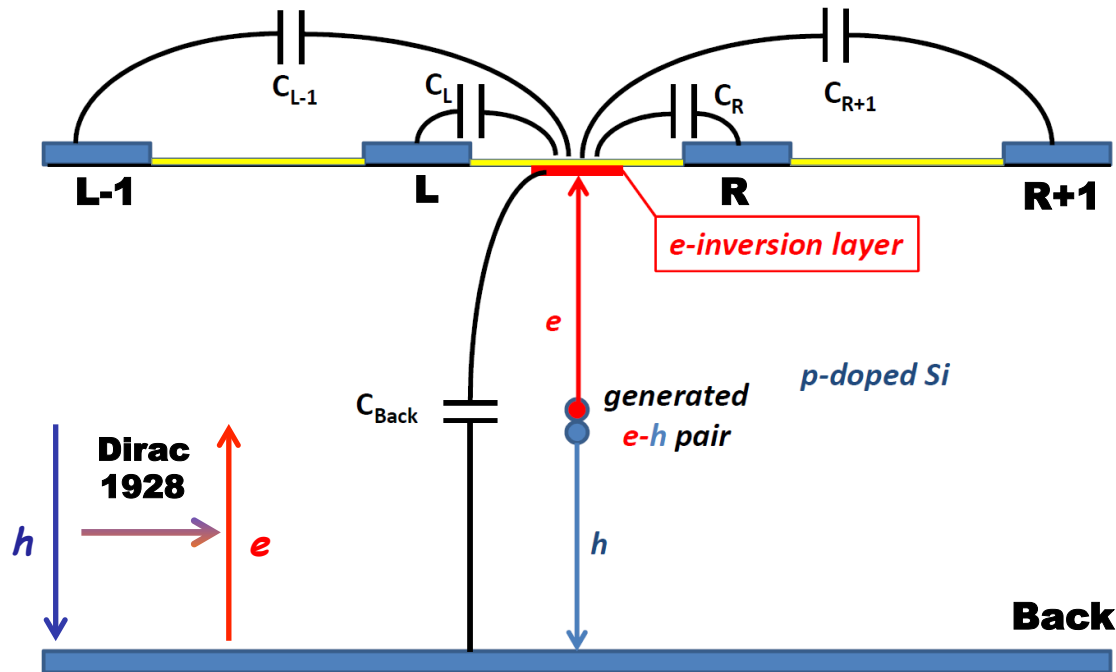
Increasing dose:

- increased charge sharing
- increased charge losses
- increase of signal in L-1 and R+1 strips

Charge sharing versus charge losses

Explained with **weighting fields** taking charge layers^{*)} into account !

(^{*)} with dielectric relaxation time $T_{\text{charge layer}} < \text{charge collection time}$)



C_i ... depend on position where e gets stuck

$$C_{\text{tot}} = \sum C_i$$

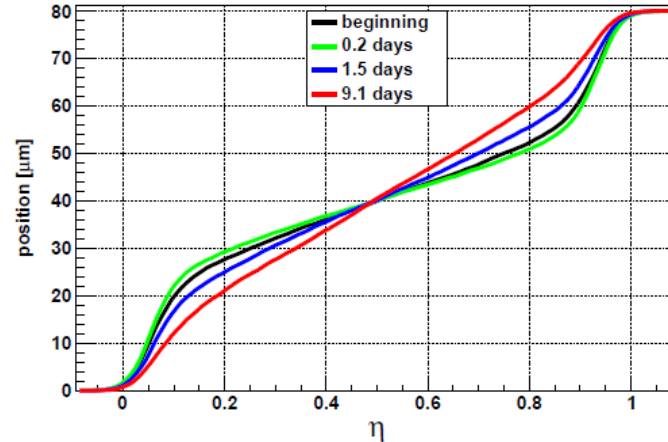
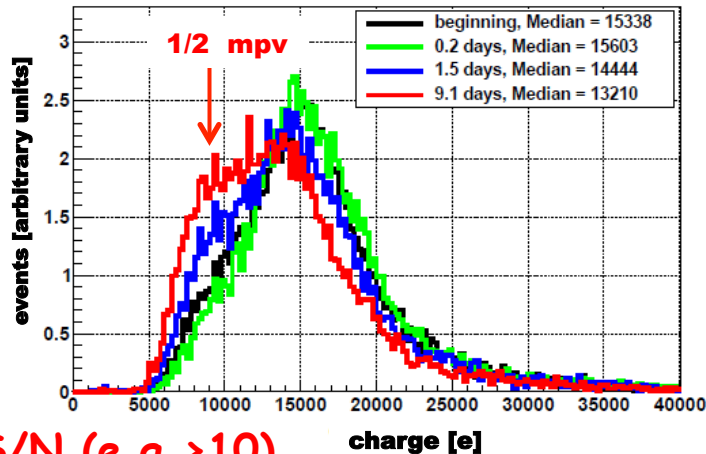
$$\text{Signal}_i = q \cdot (C_i / C_{\text{tot}}) = q \cdot [C_i / \Sigma(C_{\text{strips}} + C_{\text{back}})]$$

C_{back} determines the charge losses ($C_{\text{back}} = 0 \rightarrow \text{no losses}$)

Relevance for sensor design

Impact depends on S/N, readout scheme, track angle, dose, etc.

Here only qualitative discussion - needs quantitative estimation for a specific design



Good S/N (e.g. >10)

- analog readout: Charge Sharing improves the position resolution ($\delta \sim 1/(dx/d\eta)$) 😊
- binary readout: CS improves the resolution and worsens the track separation 😞

Poor S/N (e.g. <10)

- analog readout: as long as low signal pulses are red out, CS improves the position resolution 😊
- binary readout: unless low threshold, loss in efficiency; threshold < $0.4 \cdot \text{mpv}$
→ for 3σ noise cut $S(\text{cluster})/N > 7.5$ required 😞

Charge Sharing important for design of efficient sensor -
of similar importance as Charge Collection Efficiency



Conclusions

- Low-dose ionizing radiation changes oxide (+interface) charges
 - for n⁺p segmented sensors change of charge collection:
charge losses, charge sharing, signals in next-to-next strips
- Impact depends on track angle, signal/noise (S/N), readout
 - **good S/N**: resolution improves @ small angles
 - **poor S/N**: efficiency decreases drastically
effective threshold < 0.4 mpv → 3σ noise cut = S/N > 7.5 !
- Oxide (+other dielectrics) damages have to be taken into account in sensor design (+ sensor simulations)
 - for n⁺p **probably N(p-spray/stop) > few 10¹²cm⁻²** and broader n⁺-implants if charge sharing should be minimized
 - in addition impact on breakdown voltage + guard ring design to be considered

More work needed on understanding of charge build-up in dielectrics and interfaces (e.g. dependence on E-field, annealing, technology) and how to implement this information in realistic sensor simulations

References to Work from UHH-Group



If you did not like this talk, you will also not like the following publications (free translation from V. von Bülow "Loriot")

Wenn Sie das vorliegende Buch ungern gelesen haben, werden Ihnen diese auch nicht so recht gefallen.

V. von Bülow "Loriot"

AGIPD:

AGIPD (Adaptive Gain Integrating Pixel Detector) http://photon-science.desy.de/research/technical_groups/detectors/projects/agipd/

B. Henrich et al., The adaptive gain integrating pixel detector AGIPD a detector for the European XFEL, NIM-A 6333 Supp.(2011)S11; doi: 10.1016/j.nima.2010.06.107

Low-dose effects in segmented Si sensors:

C. Henkel, Impact of low dose-rate electron irradiation on the charge collection of n+p silicon strip sensors, [BSC thesis, University of Hamburg](#), March 2014, unpublished

J. Erfle Irradiation study of different silicon materials for the CMS tracker upgrade, [PhD thesis, University of Hamburg](#), April 2014, unpublished

Charge trapping at the Si-SiO₂ interface:

T. Poehlsen et al., Study of the accumulation layer and charge losses at the Si-SiO₂ interface in p+n-silicon strip sensors, NIM-A 721 (2013) 26; doi: 10.1016/j.nima.2013.04.026

T. Poehlsen et al., Time dependence of charge losses at the Si-SiO₂ interface in p+n-silicon strip sensors, in press NIM-A; doi: 10.1016/j.nima.2013.03.035

T. Poehlsen, Charge Losses in Silicon Sensors and Electric-Field Studies at the Si-SiO₂ Interface, [PhD thesis, University of Hamburg](#), DESY-Thesis-2013-025 (2013)

X-ray radiation damage:

J. Zhang et al., Study of radiation damage induced by 12 keV X-rays in MOS structures built on high-resistivity n-type silicon, J. Synchrotron Rad. 19 (2012) 340; doi: 10.1107/S0909049512002384

R. Klanner et al., Study of high-dose X-ray radiation damage of silicon sensors, in press NIM-A; doi: 10.1016/j.nima.2013.05.131

J. Zhang et al., X-ray induced radiation damage in segmented p+n silicon sensors, PoS (Vertex 2012) 019

J. Zhang, X-ray Radiation Damage Studies and Design of a Silicon Pixel Sensor for Science at the XFEL, [PhD thesis, University of Hamburg](#), DESY-THESIS-2013-018 (2013)

Sensor optimization for high X-ray dose :

J. Schwandt et al., Optimization of the radiation hardness of silicon pixel sensors for high x-ray doses using TCAD simulations, 2012 JINST 7 C01006; doi: 10.1088/1748-0221/7/01/C01006

J. Schwandt et al., Design of the AGIPD sensor for the European XFEL, 2013 JINST 8 C01015; doi: 10.1088/1748-0221/8/01/C01015

J. Schwandt et al., Design and First Tests of a Radiation-Hard Pixel Sensor for the European X-Ray Free-Electron Laser, accepted for publication in IEEE TNS, arXiv-140213

J. Schwandt, Design of a radiation hard pixels sensor for X-ray science, [PhD thesis, University of Hamburg](#), May 2014, unpublished

Introduction

The text

more text

and even more text

Punch line